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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Kazuo TESHIROGI et al.**

Group Art Unit: **1733**

Application Number: **10/718,653**

Examiner: **John L. GOFF**

Filed: **November 24, 2003**

Confirmation Number: **1182**

For: **FILM LAMINATION APPARATUS AND METHOD AND A MANUFACTURING
METHOD OF A SEMICONDUCTOR APPARATUS**

Attorney Docket Number: **032131**
Customer Number: **38834**

RESPONSE UNDER 37 C.F.R. §1.111

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

March 6, 2007

Sir:

This paper is filed in response to the Office Action dated December 6, 2006.

Remarks/Arguments begin on page **2** of this paper.